# **EDC 650 SERIES**

## **Complete Process Control**



#### **Proven**

Over 12,000 systems installed worldwide. **Laurell Technologies** exclusive "Dry In, Dry Out" process ensures the wafer and chemical delivery path are cleaned and dried after every use.

#### **Flexible**

Master Design with more actual processes and substrates supported than all others combined. Capable of in-situ mixing of process chemicals for ultimate flexibility.

### Safe

Interlocks and electronic safety systems combined with the highest quality construction and material use ensure the operator is protected.





## **Our Expertise at Your Convenience**



**Laurell Technologies** has 28 years of experience with our customers' complex processes, multiple chemistries, safety issues, waste containment, and disposal issues.

Benefit from our expertise and let us engineer your convenient solution.

WS-1000 Work Station EDC-650-8NPP & EDC-650-8TFM With Optional Touch Screen Interface



#### **Options and Accessories**

**WS-1000 Wet Station:** Custom designed and built by Laurell Technologies in-house

**Touch Screen Interface:** Control, program and monitor all operations with a touch

Rinse to Resistivity: Detects rinse completion and alerts the processor to dry the substrate, saving valuable resources usually wasted on a time-based system

**Multi-Position Non-Contact Level Sensing:** Either in a drain reservoir or supply container fully programmable.

**Leak Detection:** Laurell uses the most dependable sensor technology available - audible and visual alarms with industry-standard light tree

**Heated Process Chemistry:** with point-of-use or recirculation type heat exchangers

**Teflon® Housing:** We only use **semiconductor grade** Teflon® with **zero porosity** to prevent "memory" effects when changing chemicals.









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